

NIT-215

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

S. KONDO et al

Serial No. 09/637,570

Group Art Unit: 2812

Filed: August 14, 2000

Examiner: Ha T. Nguyen

For: POLISHING METHOD, METALLIZATION FABRICATION
METHOD, METHOD FOR MANUFACTURING SEMICONDUCTOR
DEVICE AND SEMICONDUCTOR DEVICE

PETITION FOR EXTENSION OF TIME

FAX RECEIVED

Commissioner for Patents
Washington, D.C. 20231

MAR 17 REC'D

TECHNOLOGY CENTER 2800

Sir:

It is respectfully requested that a one-month Extension of Time, to and including March 15, 2003, be granted in which to respond to the Office Action dated November 15, 2002 in the above-identified application.

The Commissioner is authorized to charge Deposit Account No. 50-1417 in the amount of \$110.00 for the Extension of Time fee.

The Commissioner is hereby authorized to charge any additional payment due, or to credit any overpayment, to Deposit Account No. 50-1417.

Respectfully submitted,



John R. Mattingly
Registration No. 30,293
Attorney for Applicant(s)

03/19/2003 DSASFAI 00000002 501417 09637570
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MATTINGLY, STANGER & MALUR
1800 Diagonal Road, Suite 370
Alexandria, Virginia 22314
(703) 684-1120
Date: March 17, 2003

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Amended
3/20/03